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## Response times of two-dimensional photodetectors limited by intrinsic resistance and capacitance

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**Abstract.** Most contemporary architectures of photodetectors based on two-dimensional materials include global gates for carrier density control and local  $p$ - $n$  junctions in the channel. We study the dependence of photocurrent in such detectors on the light modulation frequency, fully taking into account the effects of distributed resistance and gate-channel capacitance. The decay of photocurrent with modulation frequency governs the response time. We find that the maximum modulation frequency is largely determined by the position of light-sensitive junction with respect to the middle of the channel. Largest modulation frequency is achieved for junctions in immediate vicinity of either source or drain contacts, while fast roll-off of the modulation characteristic is observed for junction in the middle of the channel.

**Keywords:** two-dimensional materials, photodetectors, high-frequency photoresponse, distributed electronic circuits

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Конференционная статья


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## Время отклика двумерных фотодетекторов, ограниченное собственными сопротивлением и ёмкостью

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**Аннотация.** Большинство современных фотодетекторов на основе двумерных материалов имеют глобальные затворы для управления плотностью носителей заряда и локальные  $p$ - $n$ -переходы в канале. Мы изучаем зависимость фототока в таких детекторах от частоты модуляции света, полностью учитывая влияние распределенного сопротивления и распределенной емкости затвор-канал. Спад фототока с частотой модуляции определяет время отклика. Мы показываем, что максимальная частота модуляции в значительной степени определяется положением светочувствительного перехода относительно середины канала. Наибольшая частота модуляции достигается для переходов, расположенных в непосредственной близости от контактов истока или стока, в то время как быстрый спад модуляционной характеристики наблюдается для перехода, расположенного в середине канала.

**Ключевые слова:** двумерные материалы, фотодетекторы, высокочастотный фотоотклик, распределенные электрические цепи

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## Introduction

Photodetectors based on two-dimensional (2D) materials feature ultrafast response and possibility of tuning via electrical gating [1]. Response times can be divided into intrinsic times governing the formation of local photocurrent, and extrinsic times governing the formation of voltage and current in an electronic circuit. The intrinsic times in most 2D photodetectors are very short. In graphene, where photovoltage is generated via thermoelectric effect, the intrinsic time is that of carrier thermalization [2]. The latter is estimated as hundreds of femtoseconds. In 2D electron systems based on quantum wells, photocurrent generation via plasmon drag is often dominant [3]. The intrinsic time of such effect is that of momentum relaxation, on the order of 1–10 picoseconds in high-quality heterostructures [4].

We study the response time of gated 2D photodetectors vs. their structural parameters: channel resistance, channel length, gate-channel capacitance and position of the light-sensitive junction. We theoretically consider the photocurrent response  $I_{ph}$  to the radiation with modulation frequency  $f_{mod}$  and show that  $I_{ph}(f_{mod})$  drops with frequency. We show that the maximum frequency depends strongly on the position of light-sensitive junction with respect to source and drain contacts, and find that structures with photocurrent generation in the immediate vicinity of the metal leads are superior to those with junction in the mid-channel.

## Materials and Methods

Short intrinsic photoresponse implies that it can be easily masked by circuit effects, i.e. by resistive and capacitive delays. The truly external delays are minimized by matching the photodetectors with coplanar lines. However, many photodetectors have their own channel resistance and internal capacitances: the capacitance between source and drain contacts, and capacitance of the channel with respect to the gate, as shown in Fig. 1, *a*. The distributed character of resistance and capacitance in 2D detectors makes the question about  $RC$ -limited response time complex. Despite the existence of several circuit models of gated photodetectors [5, 6], it is not yet understood which resistance and capacitance govern the response time and maximum modulation frequency.

Currently, there exist two main approaches for radiation detection with 2D materials. The first one lies in the electrical induction of  $n$ - and  $p$ -type regions within the channel via application of opposite voltages to the split gates [7–9]. The gate-induced  $p$ - $n$  junction is generally located in the middle of the channel, and the photocurrent  $j_{ph}(x)$  is generated locally at the junction, Fig. 1, *b*. The second approach lies in deposition of metal contacts with dissimilar work function [10, 11], Fig. 1, *c*. Carrier diffusion between metals and 2D channel leads to the formation of  $p$ - $i$ - $n$  doping profile. The photocurrent  $j_{ph}(x)$  in such architecture is generated in the immediate vicinity of metal leads. In some rare situations, like bulk photovoltaic [12] or photon drag effects [13], the photocurrent is generated in 2D channel uniformly, Fig. 1, *d*.

We consider the photoresponse of 2D detector with channel of length  $L$ , source and drain contacts located at  $x = 0$  and  $x = L$ , respectively. The detector is globally gated, and the gate-channel separation is  $d \ll L$ . The emerging photocurrent  $I_{ph}$  is measured between source and drain contacts. We model  $I_{ph}$  at the circuit level without specifying the microscopic origin of the photoresponse. More precisely, we present the overall current density  $j(x)$  as a sum of photocurrent  $j_{ph}(x)$  and drift current  $-\sigma dV/dx$ , where  $\sigma$  is the conductivity of 2D material and  $V$  is the local voltage in the channel:

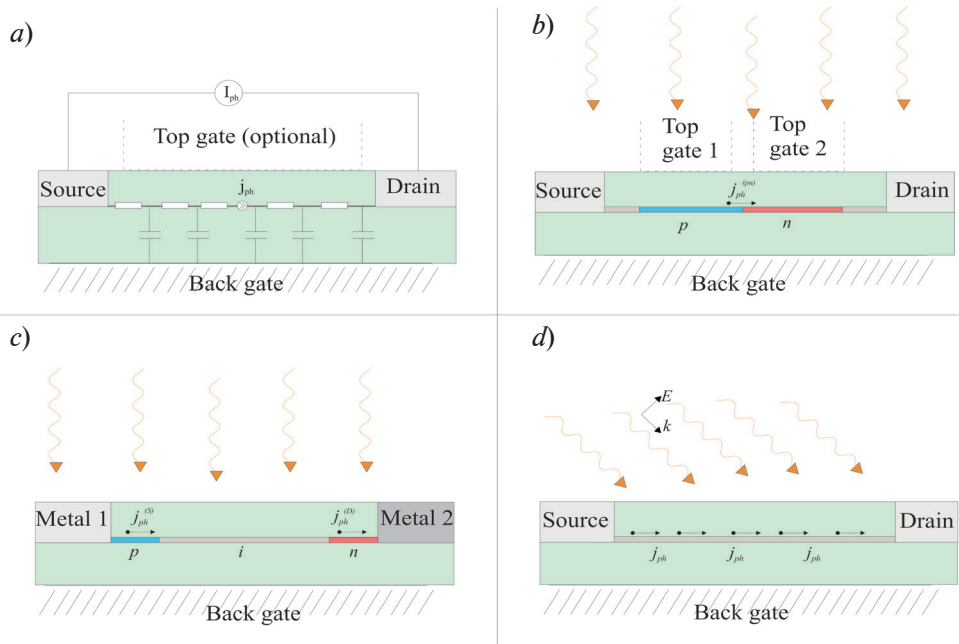


Fig.1. Schematic of the gated photodetector with 2D channel and its equivalent distributed  $RC$  circuit with localized photocurrent source (a); possible physical realizations of 2D photodetectors (b, c), fitting the scheme of panel (a): detector with  $p$ - $n$  junction induced by split gate (b), detector with  $p$ - $i$ - $n$  junction due to dissimilar metal contacts (c), detector based on photon drag effect (d)

$$j(x) = j_{ph}(x) - \sigma \frac{dV}{dx}. \quad (1)$$

The role of drift current is especially clear for localized distribution of photocurrent density, i.e., for characteristic width of the function  $j_{ph}(x)$  well below the source-drain separation  $L$ . The local electric field  $dV/dx$  in this case builds up in the regions where  $j_{ph}(x)$  is zero, such that the total current becomes spatially uniform. For time-independent illumination, requiring the spatial uniformity of the current, we find

$$I_{ph,dc} = \frac{1}{L} \int_0^L j_{ph}(x) dx, \quad (2)$$

i.e., the global photocurrent is the spatial average of local photocurrents.

The photoresponse to the modulated radiation is far less trivial. We consider the harmonic variations of local photocurrent  $j_{ph}(x, t) = j_{ph}(x)e^{-i\omega t}$ , where  $\omega = 2\pi f_{mod}$  is the modulation frequency. The buildup of local electric potential is now not instantaneous and governed by the continuity equation:

$$-i\omega\rho(x) + \frac{d}{dx} \left( j_{ph}(x) - \sigma \frac{dV}{dx} \right) = 0, \quad (3)$$

where  $\rho(x)$  is the local charge density in the channel. We link the charge density  $\rho(x)$  and electric potential  $V(x)$  via Poisson's equation. For 2D channels with proximate gates, the Poisson's equation can be solved in the local capacitance approximation:

$$\rho(x) = C_A [V(x) - V_G], \quad (4)$$

where  $C_A = \epsilon\epsilon_0/d$  is the gate-to-channel capacitance per unit area, and  $V_G$  is the gate voltage. Considering the smallness of photo-induced voltage and potential as compared to their dc values, we write  $\rho(x) = CAV(x)$ . The final equation for distribution of photoinduced potential becomes

$$V(x) + \frac{1}{q_p^2} \frac{d^2V(x)}{dx^2} = \frac{1}{i\omega C_A} \frac{dj_{ph}(x)}{dx}; \quad (5)$$

In the regime of photocurrent measurement, its boundary conditions are  $V(0) = V(L) = 0$ . Above,  $q_p = \sqrt{i\omega C_A/\sigma}$  is the complex parameter governing the spatial propagation of electric potential. In the low-frequency regime, the conductivity  $\sigma \equiv \sigma dc$  is real, and the parameter  $q_p$  is

complex,  $q_p = e^{i\pi/4} \sqrt{\omega C_A / \sigma_{dc}}$ . In such situations the spreading of potential is diffusive. Similar equation has been adopted in earlier papers [14, 15] for the analysis of plasmon-assisted resonant photoresponse of detectors.

Determination of photocurrent  $I_{ph}$  in external circuit for time-dependent response is based on Shockley–Ramo theorem. It states that  $I_{ph}$  is the weighted average of local currents

$$I_{ph} = \int_0^L g(x) j(x) dx, \quad (6)$$

where the weight function  $g(x)$  is the electric field in the channel created by unity voltage between source and drain. In the case of proximate gates considered here, the source-drain electric field is strongly screened by the gate, and persists only in the immediate vicinity of lateral contacts,  $g(x) \approx [\delta(x) + \delta(x - L)]/2$  [16]. The current measured  $I_{ph}$  in such case is the average of local currents at the source and drain:

$$I_{ph} = -\sigma \left( \left. \frac{dV}{dx} \right|_{x=0} + \left. \frac{dV}{dx} \right|_{x=L} \right). \quad (7)$$

Eq. (6) is readily solved for arbitrary spatial dependence of  $j_{ph}(x)$ , and current in external circuit is symbolically presented as

$$I_{ph} = \frac{1}{2} \int_0^L \frac{\sin[q_p x] - \sin[q_p (L - x)]}{\sin[q_p L]} \frac{dj_{ph}}{dx} dx. \quad (8)$$

The frequency dependence of photocurrent is fully encoded in parameter  $q_p(\omega) = e^{i\pi/4} \sqrt{\omega C_A / \sigma_{dc}}$ . The wave vector  $q_p(\omega)$  can be presented as  $q_p(\omega) = e^{i\pi/4} \sqrt{\omega RC / L}$ , where  $R$  is the total channel resistance and  $C$  is the total gate-channel capacitance. Thus, Eq. (8) generalizes the concept of  $RC$ -delay to the detectors with distributed resistance and capacitance.

## Results and Discussion

To highlight the dependence of response time and maximum modulation frequency on localization of light-sensitive junction, we adopt the box-shaped model of photocurrent

$$j_{ph}(x) = j_{ph}^{(0)} \theta \left[ x - (x_{ph} - w/2) \right] \theta \left[ (x_{ph} + w/2) - x \right].$$

Physically, the light-sensitive junction has length  $w$ , centered at  $x_{ph}$ , and generates constant photocurrent  $j_{ph}^{(0)}$ . The model describes all three setups of Fig. 1, *b*, *c*, *d* via appropriate choice of  $x_{ph}$  and  $w$ . Plugging the model photocurrent distribution into expression (8), we find the current in external circuit:

$$I_{ph}(\omega) = j_{ph}^{(0)} \sin \left( \frac{q_p w}{2} \right) \left[ \cos(q_p x_{ph}) \cot \left( \frac{q_p L}{2} \right) + \sin(q_p x_{ph}) \right]. \quad (9)$$

Eq. (9) is our central result. Figure 2 shows the computed dependences of  $I_{ph}$  on modulation frequency at various junction positions  $x_{ph}$  and small junction width  $w = L/20$ . The model parameters are adequate for contemporary graphene detectors,  $L = 10 \mu\text{m}$ ,  $d = 100 \text{ nm}$ ,  $\sigma^{-1} = 100 \text{ Ohm}$ ,  $\varepsilon = 4$ . We observe that the frequency roll-off of the photocurrent is fastest when the junction is positioned in the middle of the channel, and becomes slower as the junction gets closer to the source. The dependence  $I_{ph}(\omega)$  is symmetric with respect to the mid-channel, i.e. the frequency roll-off is identical for  $x_{ph} = x_0$  and  $x_{ph} = L - x_0$ . The computed dependence supports our intuition about the propagation of photovoltage signals in distributed photodetectors. If the photocurrent is generated away from the source and drain, it takes a long time for the signal propagation to the contacts, therefore the maximum modulation frequency is low. On the contrary, for signal generated in immediate vicinity of either contact, the  $RC$ -limited response time is very short. Only a small fraction of channel resistance and gate-channel capacitance contributes to the apparent  $R$  and  $C$ . For very small separations between junction and the contact (case  $x_{ph} = L/5$  in Fig. 2), the photocurrent can even initially grow with frequency.

At very high frequencies the photocurrent eventually decays according to the asymptotic law

$$I_{ph}(\omega) = j_{ph}^{(0)} \frac{q_p W}{2} \exp\left(-\frac{|q_p|}{\sqrt{2}} \min\{x_{ph}, L - x_{ph}\}\right). \quad (10)$$

The maximum modulation frequency  $f_{mod}^{max}$ , i.e., the frequency at which the photodetector response drops by  $e$  times, is given by

$$f_{mod}^{max} = \frac{1}{\pi RC} \frac{L}{\min\{x_{ph}, L - x_{ph}\}}. \quad (11)$$

An intuitive interpretation of (11) is the following: only a fraction of total resistance and capacitance located between the light-sensitive junction metal contact is relevant to the  $RC$ -delay of the distributed photodetector.

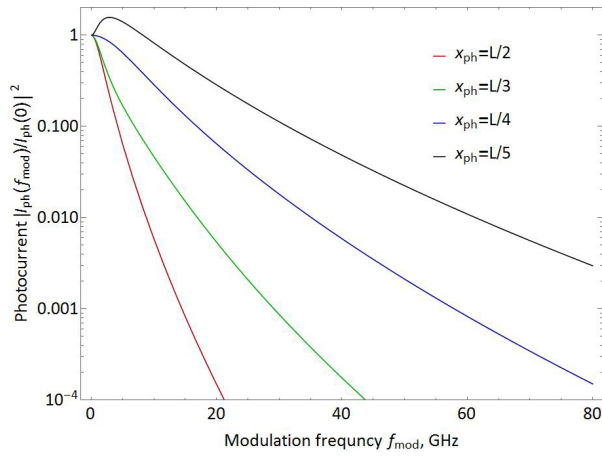


Fig. 2. Dependence of photocurrent on modulation frequency  $f_{mod} = \omega/2\pi$  computed with Eq. (9) for different positions of the light-sensitive junction  $x_{ph}$ . Detector parameters are channel length  $L=10 \mu\text{m}$ , gate-channel separation  $d = 100 \text{ nm}$ , gate dielectric constant  $\epsilon = 4$ , channel resistivity  $\sigma^{-1} = 100 \text{ Ohm}$ .

$f_{rad} = 100\text{--}300 \text{ GHz}$ . The applicability of our model is limited to tens of gigahertz in that case. For optical fiber detectors ( $\lambda = 1.55 \mu\text{m}$ ,  $f_{rad} \approx 200 \text{ THz}$ ), the applicability of the model is very broad and definitely covers the contemporary achievable modulation frequencies.

### Conclusion

We generalized the concept of  $RC$  delay to the photodetectors based on 2D materials with global gates and local light-sensitive  $p$ - $n$  junctions. We shown that ‘proper’ resistance and capacitance governing the maximum modulation frequency and the response time are those of the part of the channel between light-sensitive  $p$ - $n$  junction and most proximate contact (either source or drain). We derived a general expression for the frequency roll-off of the photoresponse valid at arbitrary light modulation frequencies and arbitrary distribution of the photocurrent within the channel.

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